



The 23rd CCPR Meeting

The HKSARG Standards & Calibration Laboratory (SCL)

Dennis Lee

Head, SCL

23 September 2016

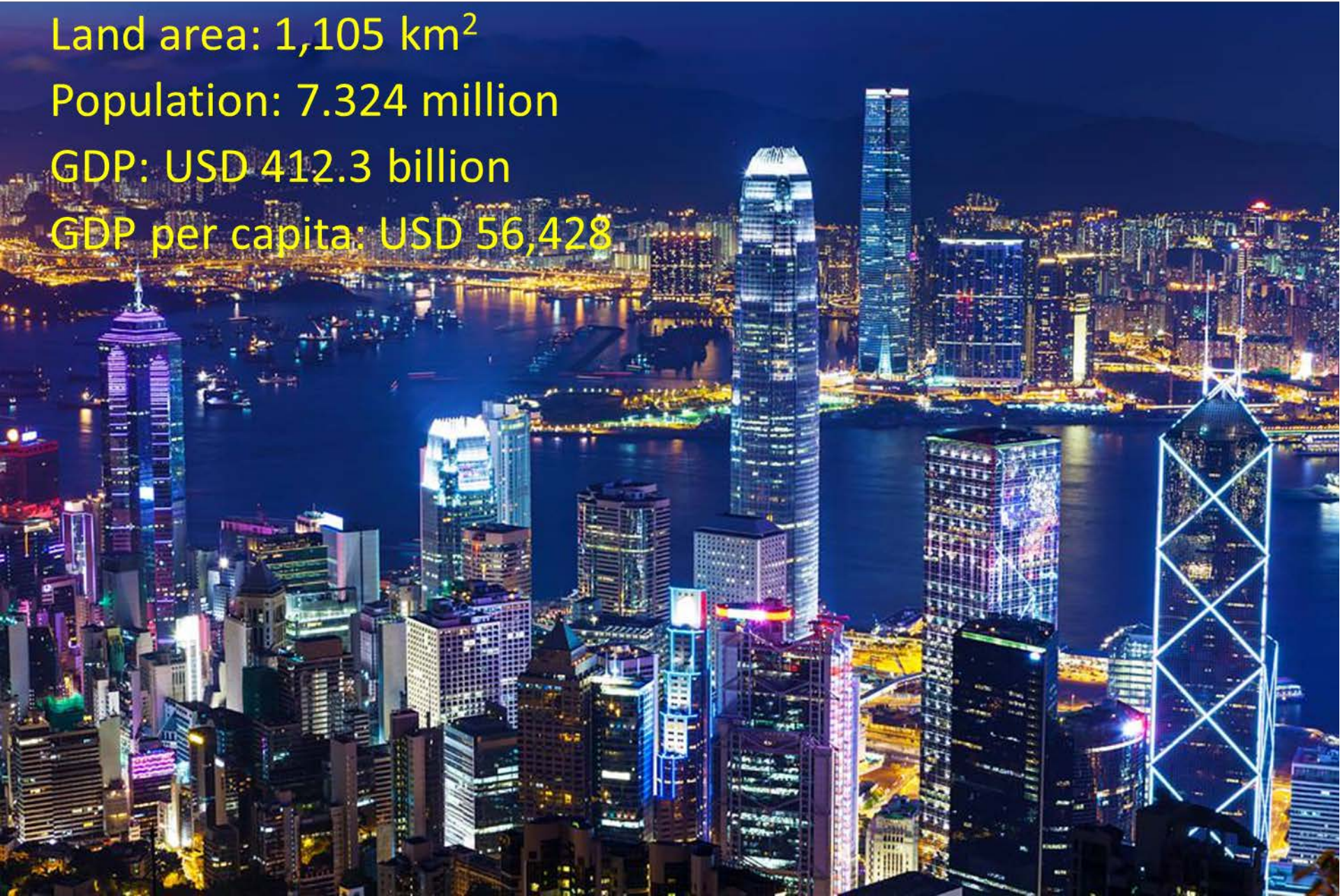


Land area: 1,105 km²

Population: 7.324 million

GDP: USD 412.3 billion

GDP per capita: USD 56,428





Contents

- The Standards and Calibration Laboratory (SCL)
- Photometry and Radiometry Facilities at SCL
- The Challenges Ahead for SCL
- SCL as an Official CCPR Observer for Hong Kong



Metrology Infrastructure of Hong Kong

Legislation of Hong Kong on Weights & Measures

Chapter:	68
Section:	8
Title:	Weight and Measures Ordinance
Heading:	Reference standards of weights and measures The reference standards shall be in the custody of the Commissioner for Innovation and Technology ⁽¹⁾ (3): or the Government Chemist ⁽²⁾ who shall lodge them at a Government laboratory.

Notes:

(1) The HKSARG Standards and Calibration Laboratory (SCL) is Hong Kong's custodian of physical reference standards.

(2) The Government Laboratory (GL) is Hong Kong's custodian of chemical reference standards.



SCL as Hong Kong's Metrology Infrastructure

- **Chemical Metrology**

The Government Laboratory (GL): **103 years** of Analytical, Advisory and Forensic Science Services



- **Physical Metrology**

The Standards and Calibration Laboratory (SCL): **32 years** of Physical Metrology Services



Wan Chai Main Lab (All physical measurements)



Kowloon Bay Branch (Force)



Representation of HKSAR for Metrology Matters

The Basic Law of the Hong Kong Special Administrative Region of the People's Republic of China

Article 139

The Government of the Hong Kong Special Administrative Region shall, on its own, formulate policies on science and technology and protect by law achievements in scientific and technological research, patents, discoveries and inventions. **The Government of the Hong Kong Special Administrative Region shall, on its own, decide on the scientific and technological standards* and specifications applicable in Hong Kong.**

Note*: By Article 139 of the Basic Law, the SCL and GL represent Hong Kong as the Metrology Institutes on measurement matters.



SCL as an Associate of the CGPM

I declare as director of the designated national metrology institute of an Associate State or Economy of the CGPM that I wish to participate in this Mutual Recognition Arrangement and agree to abide by the rules and procedures of the arrangement.

Nom/Name LNMI/NMI*	État ou entité économique associé(e) à la CGPM/Associate State or Economy of the CGPM	BIPM
Signature		Signature
Lo Chung-ming	The Government of the Hong Kong Special Administrative Region Standards and Calibration Laboratory (SCL)	Hong Kong, China 10 June 2000 <i>Lo Chung-ming</i>

Je déclare, en tant que directeur du laboratoire national de métrologie désigné par l'État ou l'entité économique associée à la Conférence générale des poids et mesures, que je respecterai les règles et procédures de cet arrangement.

I declare as director of the designated national metrology institute of an Associate State or Economy of the CGPM that I wish to participate in this Mutual Recognition Arrangement and agree to abide by the rules and procedures of the arrangement.

Nom/Name LNMI/NMI*	État ou entité économique associé(e) à la CGPM/Associate State or Economy of the CGPM	BIPM
Signature		Signature
Lo Chung-ming	The Government of the Hong Kong Special Administrative Region Standards and Calibration Laboratory (SCL)	Hong Kong, China 10 June 2000 <i>Lo Chung-ming</i>

Explicative Note
People's Republic of China, the HKSAR is authorised by the Government of the People's Republic of China to, on its own, decide on the scientific and technological standards applicable in Hong Kong. SCL is the metrology institute designated by the Government of the HKSAR as responsible for measurement standards. Any reference to "national" measurement standards and metrology institutes should be treated, in relation to Hong Kong, China, as a reference to the measurement standards and the metrology institute of the HKSAR respectively.

Under the Basic Law of the Hong Kong Special Administrative Region (HKSAR) of the People's Republic of China, the HKSAR is authorised by the Government of the People's Republic of China to, on its own, decide on the scientific and technological standards applicable in Hong Kong. SCL is the metrology institute designated by the Government of the HKSAR as responsible for measurement standards. Any reference to "national" measurement standards and metrology institutes should be treated, in relation to Hong Kong, China, as a reference to the measurement standards and the metrology institute of the HKSAR respectively.



SCL's Participation in International Metrology Organizations

APMP: Full Member since 1997

CGPM: Associate since 8 Apr 2000

CIPM MRA: signed on 31 May 2000

CMCs in KCDB: since 19 Apr 2001

CIPM MRA logo: approved to use since 24 Aug 2010

GULFMET: Associate since 25 Dec 2014



GULFMET- Gulf Association for Metrology
AFRIMETS- Intra-Africa Metrology System
APMP- Asia Pacific Metrology Programme
COOMET- Euro-Asian Cooperation of National Metrological Institutions
EURAMET- European Association of Metrology Institutes
SIM- Inter-American Metrology System





SCL's CMCs listed on the BIPM website

http://www.bipm.org/utils/common/pdf/KCDB/KCDB_CMCs.pdf

Member State Associate of the CGPM International Organization
Distribution of CMCs recorded in the KCDB
The meanings of the acronyms are given in the last page of this document

Country	AUV				Mass and Related Quantities									Length		PR		TF		EM			
	A	W	V	Total	Mass 1	Dens 2	Pres 3	F 4	Torq 5	Visc 6	H 7	Grav 8	FF 9	Total	Laser	Dim Met	Total	Total	Total		Total	Matrices	
Albania				7										7									
Argentina	5	4	9	20	16	13	11						4	73		10	10	3	17		78	Yes (21)	
Australia	13	10	23	18	2	4	5							29		6	6	17	26	21	114	Yes (10)	
Austria	17	6	23	8	2	7	4			7	4	1	20	62	5	22	27	4	20	17	36	Yes (10)	
Bangladesh																							
Belarus	8			8	6					2	1			9	1	12	13	3	37	31	39	Yes (2)	
Belgium				10		2	3							15	3	14	17			20			
Bolivia																							
Bosnia and Herzegovina				7																			
Botswana																							
Brazil	57	31	88	27	4	14	16	1	22				4	88	2	17	19	11	11	13	131	Yes	
Bulgaria	12	18	30	8	15					1				24	3	15	18	6	32	16	58	Yes (33)	
Canada	18	2	8	28	32	8	9						3	52	10	9	19	68	64	7	236	No	
CARICOM																							
Chile				24				9						33		1	1			10			
China	19	3	31	53	10	4	8	3	1	15	14		12	67	2	48	50	27	30	28	238	Yes (15)	
Chinese Taipei	21	18	39	10			12	4					21	50	1	38	39	45	27	8	140	Yes	
Colombia				24										8	32					8		54	Yes
Costa Rica														10	3	15	18			32		21	Yes (12)
Croatia							10							12	12					8			
Cuba														20	47	15	62	77	20	45	17	75	Yes (47)
Czech Republic	4	4	8	10			12	4	1				36	61	15	15	8	23			55	Yes (8)	
Denmark	20	2	31	7			14	4						20									
Ecuador				20										23	2					4	2	Yes (1)	
Egypt				7		6	4	1	5														
ESA																							
Estonia																							
Finland	17	13	30	8	2	14						1	3	28	11	48	59	53	44	11	99	Yes (38)	
France	57	2	59	10	12	19	8	5	31				17	162	5	22	27	29	101	11	115	Yes (51)	
Georgia														9									
Germany	18	5	53	76	10	22	23	10	4	67	24		40	200	4	90	94	76	116	25	160	Yes (54)	
Ghana																							
Greece				9										15	24	2	2	4		54		38	Yes (12)
Hong Kong, China	15		15	9	6	6	4	3		6			34	2	11	13			30	29	200	Yes	
Hungary	6	8	14	16	8					5			8	59	3	16	19	57	36	5	85	Yes	
IAEA																							
India	23	11	34	16	2	17	6	1	6	3			3	54	2	45	47	14	4	11	95	Yes (25)	
Indonesia	15		15	24		3								27		5	5			11		49	No
Iraq																							
Ireland	4		4	7										7		13	13			33	7	170	Yes
IRMM																							
Israel																							
Italy	23	2	17	42	8	8	14	7		29	15	1	16	98	7	36	43	23	62	14	108	Yes (31)	
Jamaica														22									
Japan	4	4	8	12	7	11	3	3	28	3			26	93	7	38	45	49	44	27	117	Yes (29)	
Kazakhstan				6									8		14	3	3	6			5	4	
Kenya																							

Ghana	26		15				1															164	
Hong Kong, China				3	3		4	1					1	9	13		5			39		360	
Hungary	28	28	104			10		2	4											26		392	
IAEA	22		22																			22	
India							1															260	
Indonesia																						107	
Iraq																						0	
Ireland																						234	
IRMM		110		110	30	9	10		4				9	17	6	2	30					227	
Israel																						0	
Italy	76	13	9	98			3			2	3	2	2									500	
Jamaica																						22	
Japan	18	217	13	248	70	27	12	158	22	6			3	13	5	111						1130	
Kazakhstan																							29
Kenya																							1



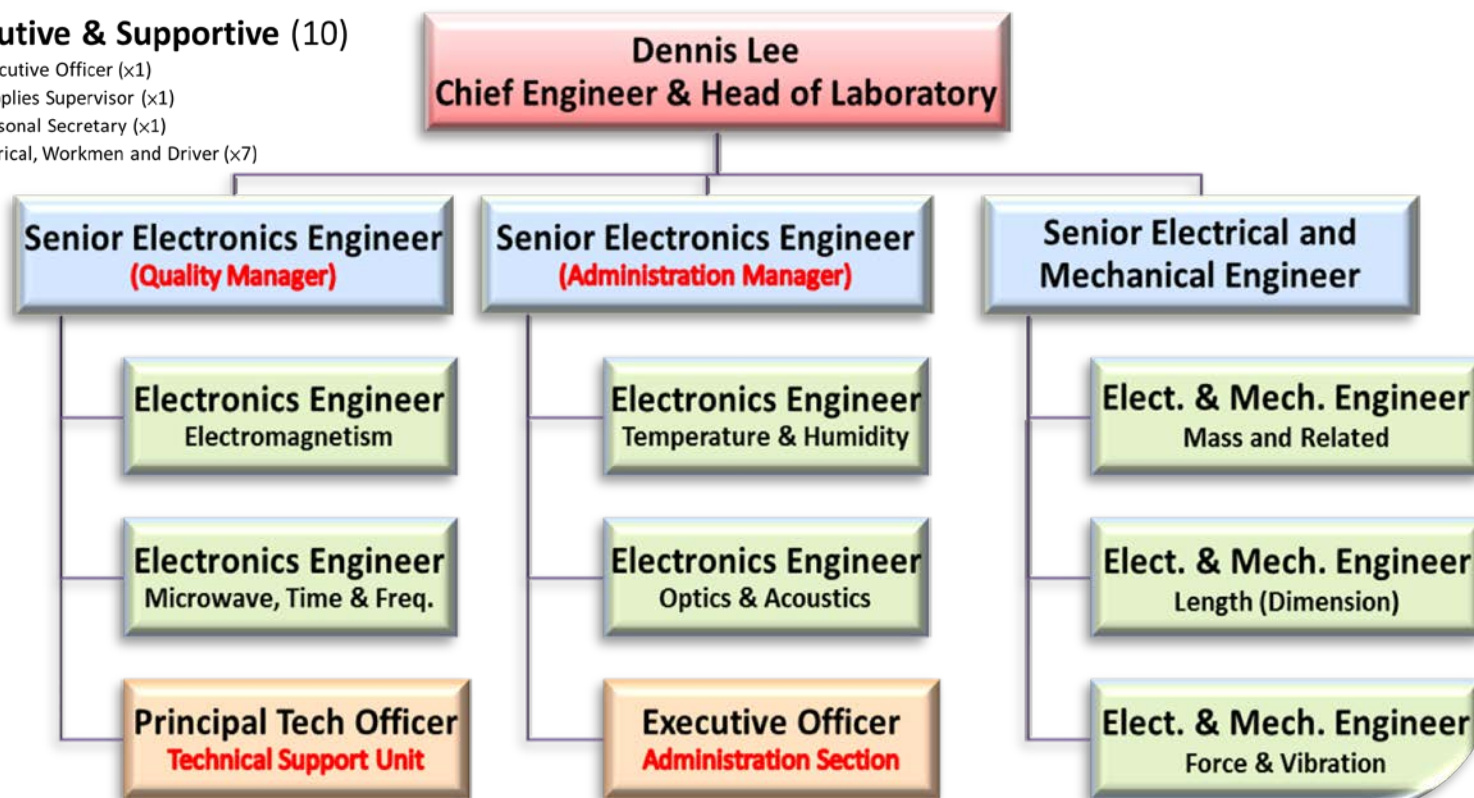
SCL's first 30 years: 1984 to 2014

1977	Hong Kong became a member economy of the Asia Pacific Metrology Program (APMP), the oldest regional metrological specialist body.		1997 and 2000	SCL was renamed as "The HKSARG Standards and Calibration Laboratory (SCL)" and came under the Innovation and Technology Commission (ITC).	
1978	Consultancy study was conducted on the needs for a metrology infrastructure for Hong Kong by Mr CH Dix, NPL(UK).		1998	SCL established the Iodine stabilized Helium Neon laser, at 633 nm, as HK's primary standard for length with traceability to the SI.	
1979	A government primary standards laboratory was recommended to be established by the Advisory Committee on Diversification, initially in the fields of electrical and electronics measurements.		2000	SCL established the Quantum Hall Resistance Standard (an agreed representation of SI for ohm) as HK's primary standard for electricity.	
1984	"The HKS Standards and Calibration Laboratory (SCL)" was established, initially for Electricity & Thermometry, under the Industry Department.		2000	SCL became an Associate of CGPM and signatory of the CIPM MRA.	
1986	SCL established the Cesium Beam Electron Clock (primary realisation of the SI unit for Hz) as HK's primary standard for frequency.		2001	SCL's 1 st batch of Calibration and Measurement Capabilities (CMC) published on the Appendix C of the CIPM MRA.	
1986	SCL acquired the British Calibration Service, BCS, accreditation status. (BCS became National Measurement Accreditation Service, NAMAS and then United Kingdom Accreditation Service, UKAS, later on.)		2001	A consultancy study was conducted on the role of SCL by Dr Inglis, Director of National Measurement Laboratory, CSIRO, Australia.	
1987	SCL established the water triple point cells (primary realisation of the SI unit for K) as HK's primary standard for temperature.		2001	SCL established the Force Laboratory at the PWCL Building for calibration up to 3000 kN.	
1987 to 1994	The following mechanical measurement standards were set up: Mass, Length, Pressure, Volume, Torque, Hardness.		2005	SCL established the facility for calibration of instruments for ultrasonic fault detection and electromagnetic compatibility testing	
1993	SCL acquired the BIPM Kilogram Prototype No. 75 as HK's primary mass standard with traceability directly to the SI.		2005	SCL established the Acoustics Laboratory with all results traceable to the SCL primary standard (for sound level, noise dosimetric and audiometric measurement).	
1994	SCL established the High Voltage Laboratory capable for calibration of direct current electricity up to 100 kV.		2008	SCL embarked on nano-metrology activities (typically for investigation of the relationship between optical and physical positions).	
1994	SCL established the Josephson Array Voltage Standard (an agreed representation of SI for volt) as HK's primary standard for electricity.		2011	SCL established the facility for magnetic measurement.	
1994	SCL stopped seeking accreditation by NAMAS and changed to the Hong Kong Laboratory Accreditation Scheme (HOKLAS).		2012	SCL established the facility for air speed measurement.	
1996	SCL established the micro-calorimeter as HK's primary standard for radio frequency power with traceability to the SI.		2013	SCL established the facility for photometry and radiometry for calibration of quantities related to luminous intensity in the unit of candela.	
1997	The Asia Pacific Metrology Program (APMP) Memorandum of Understanding (MoU) was drafted and SCL was the MOU signatory.		2014	SCL celebrates its 30 th Anniversary!	



Organization Structure of SCL

- **Professional (11)**
 - HL (Chief Engineer x1)
 - SLs (Senior Engineers x3)
 - ELs (Engineers x7)
- **Technical (23)**
 - PT (Principal Technical Officer x1)
 - STOs (Senior Technical Officers x11)
 - TOs (Technical Officers x11)
- **Executive & Supportive (10)**
 - Executive Officer (x1)
 - Supplies Supervisor (x1)
 - Personal Secretary (x1)
 - Clerical, Workmen and Driver (x7)



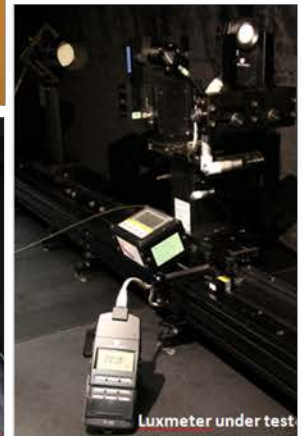
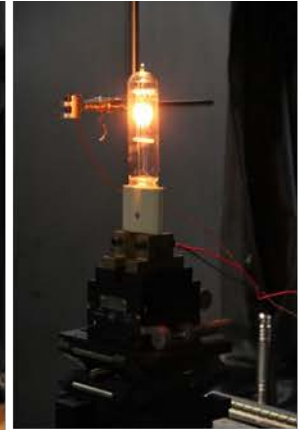
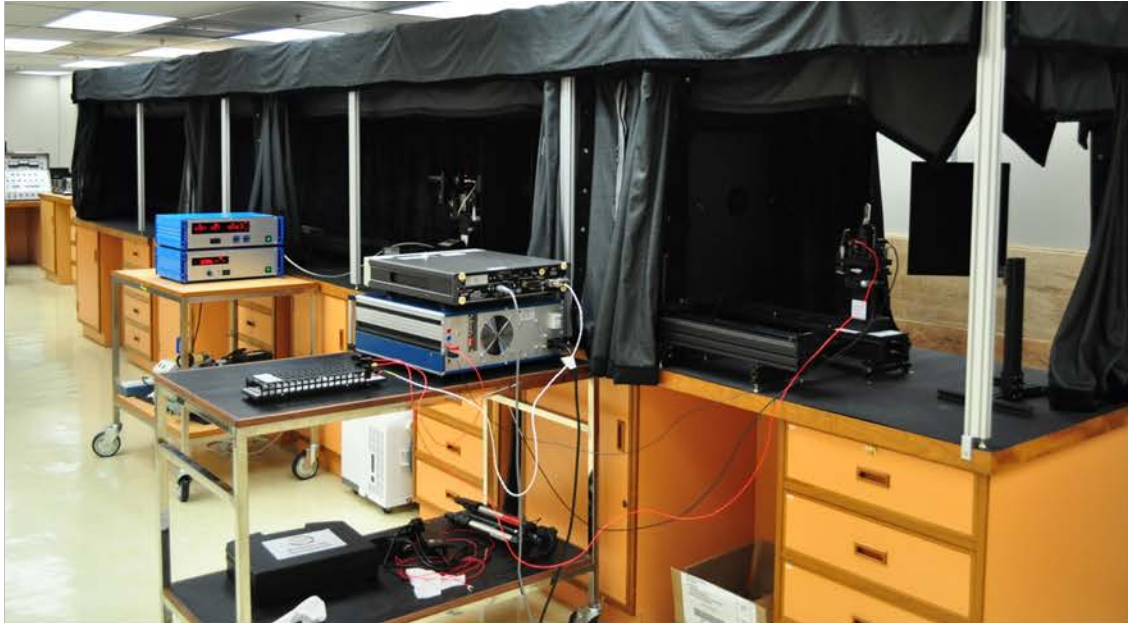


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SCL's Photometry and Radiometry Capabilities

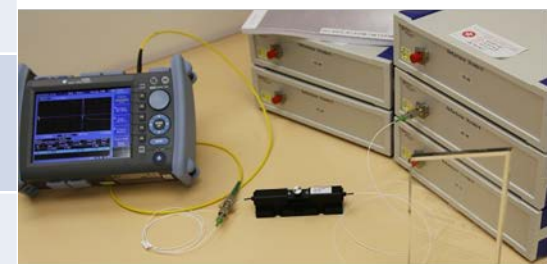
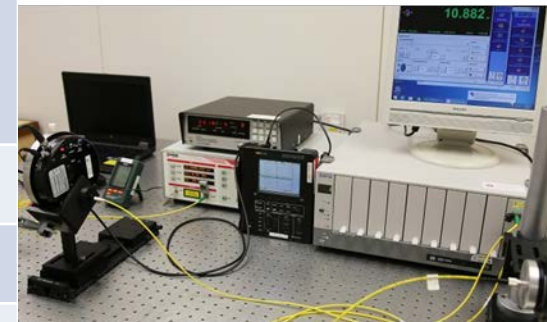
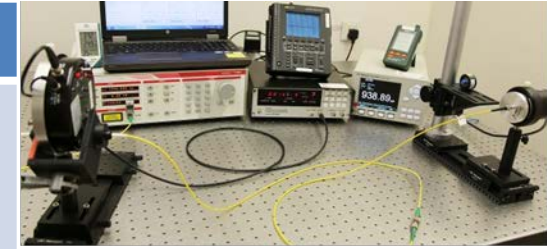


It started on some wooden benches in the direct current electrical laboratory in 2012.



SCL's Accredited Optical Calibration Services

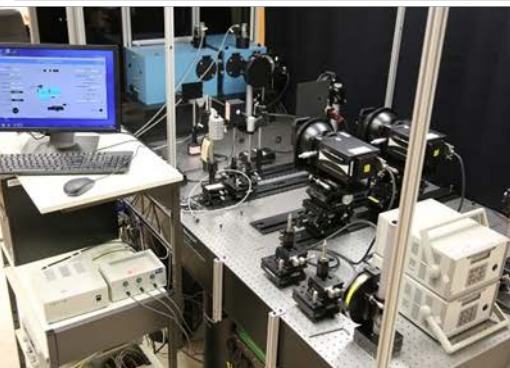
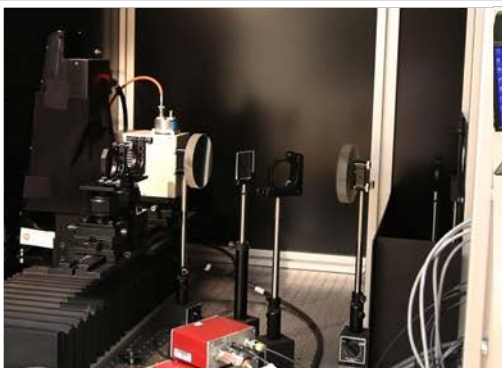
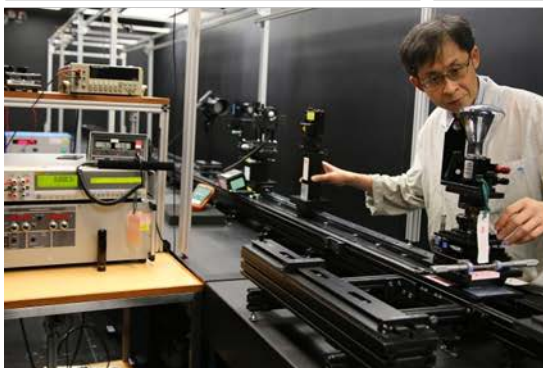
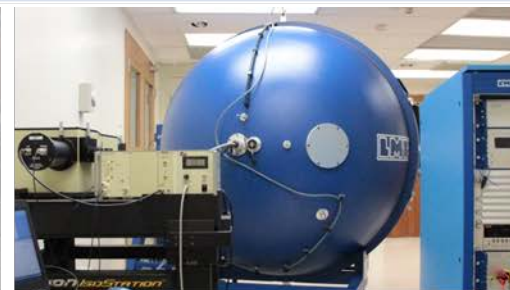
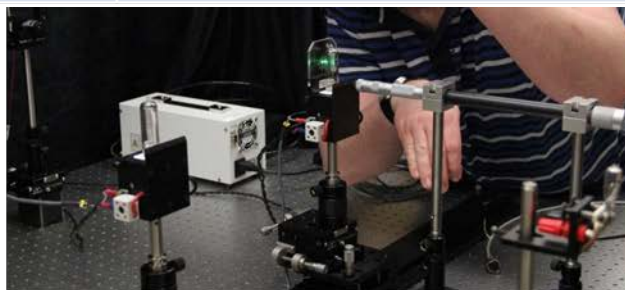
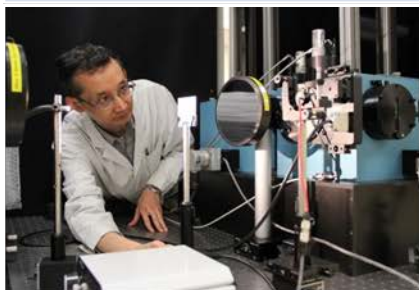
Item / Materials to be tested	Parameters
Light Sources	Total Luminous Flux Luminous Intensity Correlated Color Temperature Spectral Radiant Flux Spectral Irradiance / Radiance
Luxmeters	Illuminance
Broadband Detectors	Spectral Power Responsivity
Optical Filters	Regular Spectral Transmittance
Optical Time Domain Reflectrometers	Location, Loss, Reflectance deviation
Optical Fibre Power Meter, Laser Source, Wavelength Meter	Power, Wavelength
Optical Fibre attenuator	Absolute attenuation, step attenuation





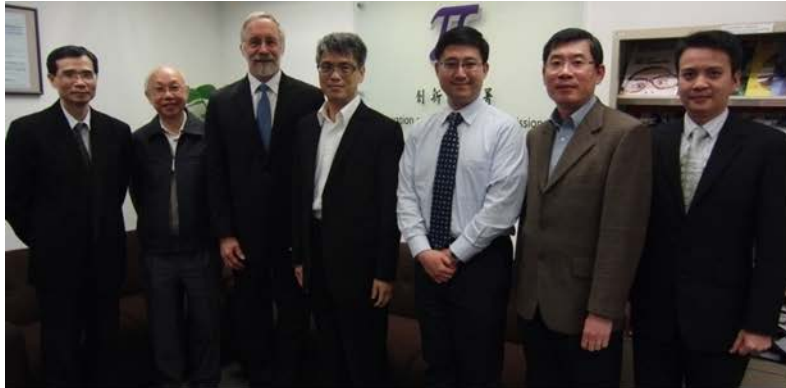
SCL's Accredited Optical Proficiency Testing Service

Proficiency Testing Item	Measurement Range
Illuminance Meter	Illuminance at color temperature of 2856 K over 1 lx to 3000 lx
Tungsten Standard Lamp	Luminous intensity at color temperature of 2856 K at nominal values of 280 cd and 1000 cd
Unfiltered photometer	Spectral power responsivity over the wavelength range from 300 nm to 1000 nm

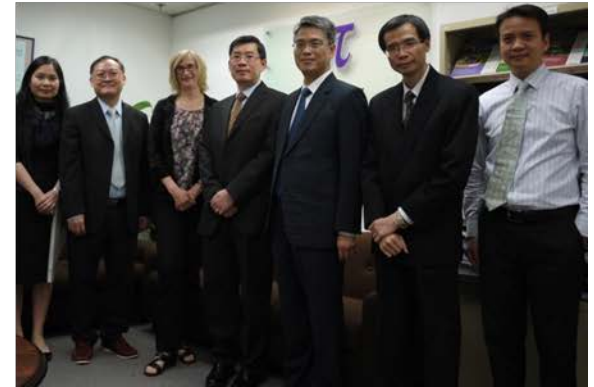
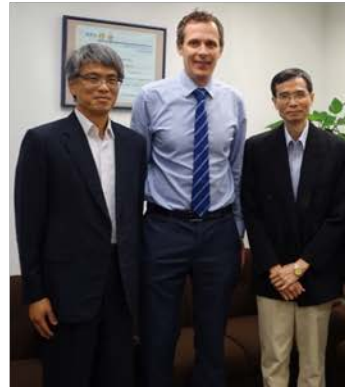




Accreditation of SCL's optical PTP service



Accreditation of SCL's optical calibration service



Date	Peer Reviewer	Area
Nov 12	Liu Yuanjie, NMC, A* Star	Illuminance
Nov 14	Teresa Goodman, NPL(UK)	Special Radiance & Irradiance
Jul 15	Dan Tholen, convener of WG for ISO/IEC 17043	Proficiency Test Provider
Aug 15	Andrew Deadman, NPL (UK)	Luminous and Radiant Flux



SCL Photometry & Radiometry Calibration Service

Customer (Outside Hong Kong)	Equipment
Agencia Comercial Wardley Lda. (Macau SAR)	Illumin. Meter
SONJU Engineering Services (Philippines)	Light Meter
Stryker China Limited (Mainland China)	Light Meter
Waga Calibration Svc. (PVT) Ltd. (Sri Lanka)	Chroma Meter



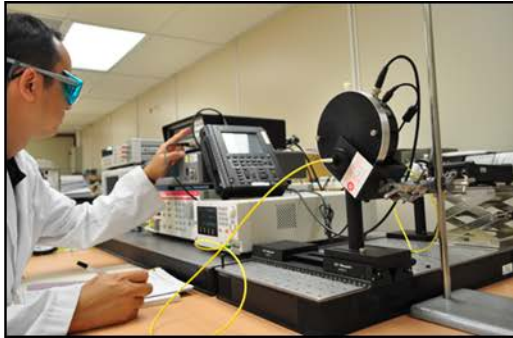
Customer (Public Sector)	Equipment
Government Laboratory	Light Meter
Highways Department	Lux Meter
Labour Department	Illuminance Meter
Leisure and Cultural Services Department	Lux Meter



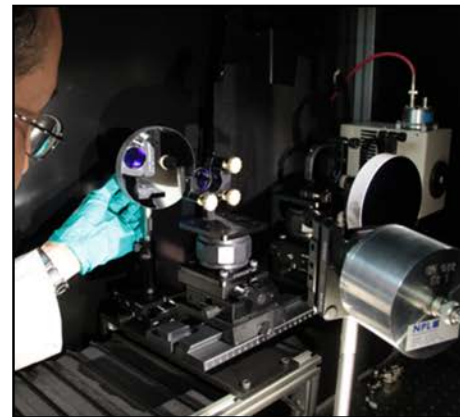
Customer (Private Sector)	Equipment
Intertek Testing Services Hong Kong Ltd	Standard Lamp & Light Meter
Hong Kong Productivity Council	Standard Light Source
API Lab Testing Limited	Luxmeter
C & K Instrument (HK) Ltd.	Standard Illuminance Meter
Geotechnics & Concrete Engineering (HK) Ltd	Luxmeter
Goodrich Asia-Pacific Ltd.	Light Meter
Hong Kong Calibration Ltd.	Standard Illuminance Meter
Iu Cheong Electric Co Ltd	Light Meter
JFC Testing and Inspection Company Limited	Light Meter
Lee & Co., Engineering Ltd.	Light Meter
Mak Hang Kei (HK) Construction Limited	Standard Illuminance Meter
Maxlab Calibration Centre Limited	Luxmeter
Takasago Thermal Engineering Co Ltd	Light Meter



Other Optical Calibration Services



Optical Fiber Power Sources/Meters and Optical Time-Domain Reflectometers
(Photonic Measurements for Optical Communications)



Standard Reference Glass Filters
(Spectrophotometry: Spectral Transmission)

Technical Publications



Commission on Illumination (CIE) Conference (2015)

EVALUATION OF MEASUREMENT UNCERTAINTY FOR PHOTOMETRIC, RADIOMETRIC AND PHOTONIC MEASUREMENTS IN ACCORDANCE WITH THE JCGM100:2008 AND JCGM 101:2008 AT THE STANDARDS AND CALIBRATION LABORATORY OF HONG KONG

Author(s): Lee, W.K. Dennis, Yan, Y.K. Aaron, Lam, H.S. Brenda, Ko, C.K. Samuel
The Government of the Hong Kong Special Administrative Region, Standards and Calibration Laboratory (SCL)
Abstract: SCL has developed new capabilities in photometric, radiometric and photonic measurements. The measurement systems, measurement models and uncertainty evaluation in accordance with the JCGM 100 are described. This paper also detailed the use of the SCL in-house developed software tool to validate the uncertainty estimation in accordance with the JCGM 101.

1. Photometric measurement

The measurement model of photometric meter calibration is as follows:

$$E_{v, \lambda} = \frac{P_{\lambda}}{4\pi r^2} \cdot \cos^2 \theta \cdot \tau_{\lambda} \cdot \tau_{\text{opt}} \cdot \tau_{\text{det}} \cdot \tau_{\text{elec}}$$

Where:
 $E_{v, \lambda}$ is the irradiance for the reading of the reference distance meter;
 P_{λ} is the radiant power of the reference distance meter;
 r is the distance from the lamp to the reference distance meter;
 θ is the distance from the lamp to the reference distance meter;
 τ_{λ} is the distance from the lamp to the reference distance meter;
 τ_{opt} is the distance from the lamp to the reference distance meter;
 τ_{det} is the distance from the lamp to the reference distance meter;
 τ_{elec} is the distance from the lamp to the reference distance meter.

3. Photonic measurement

The measurement model of optical power meter calibration is as follows:

$$P_{\lambda} = \frac{P_{\text{ref}}}{k_{\text{ref}}} \cdot k_{\text{meas}}$$

Where:
 P_{λ} is the radiant power of the reference distance meter;
 P_{ref} is the radiant power of the reference distance meter;
 k_{ref} is the radiant power of the reference distance meter;
 k_{meas} is the radiant power of the reference distance meter.

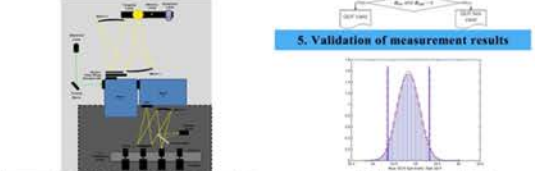


2. Radiometric measurement

The measurement model of spectral irradiance and radiance calibration is as follows:

$$E_{\lambda} = \frac{P_{\lambda}}{4\pi r^2} \cdot \cos^2 \theta \cdot \tau_{\lambda} \cdot \tau_{\text{opt}} \cdot \tau_{\text{det}} \cdot \tau_{\text{elec}}$$

Where:
 E_{λ} is the spectral irradiance of the reference distance meter;
 P_{λ} is the radiant power of the reference distance meter;
 r is the distance from the lamp to the reference distance meter;
 θ is the distance from the lamp to the reference distance meter;
 τ_{λ} is the distance from the lamp to the reference distance meter;
 τ_{opt} is the distance from the lamp to the reference distance meter;
 τ_{det} is the distance from the lamp to the reference distance meter;
 τ_{elec} is the distance from the lamp to the reference distance meter.



Year	Standard	Method	U	k	Value	Unit
2015	IEC 61749-1	Electrical	0.001	2	1.000	W
2015	IEC 61749-2	Electrical	0.001	2	1.000	W
2015	IEC 61749-3	Electrical	0.001	2	1.000	W
2015	IEC 61749-4	Electrical	0.001	2	1.000	W
2015	IEC 61749-5	Electrical	0.001	2	1.000	W
2015	IEC 61749-6	Electrical	0.001	2	1.000	W
2015	IEC 61749-7	Electrical	0.001	2	1.000	W
2015	IEC 61749-8	Electrical	0.001	2	1.000	W
2015	IEC 61749-9	Electrical	0.001	2	1.000	W
2015	IEC 61749-10	Electrical	0.001	2	1.000	W

NCSLI Measure Journal (2015)

Calibration of Optical Fiber Laser Sources

Samuel C. K. Ko, Aaron Y. K. Yan, and Barry K. Y. Chan

Abstract: A calibration system for optical fiber laser sources has been developed at the Government of the Hong Kong Special Administrative Region Standards and Calibration Laboratory (SCL). The measurements of wavelength, output power level and output power stability of optical fiber laser sources fitted with fiber channel-mated physical contact (FC/APC) connectors are detailed. The wavelength is directly measured by the laboratory wavelength meter. The standard measurement uncertainty obtainable by this calibration method is less than 1 picometer (pm). The output power is the summation of the measured power by the laboratory's electrically calibrated pyroelectric radiometer (ECPR), and the insertion loss between the source and the ECPR with a standard measurement uncertainty of about 3.7%. The output power stability is evaluated by measuring the maximum and minimum fluctuation of the measured optical power using the laboratory ECPR which has three significant digits of resolution.

1. Introduction

The demand for fiber to the home (FTTH) has been growing rapidly in recent years. As a result, optical testing technology for the construction and maintenance of optical fiber cable networks has become important [1]. The fiber optic power meter, fiber optic source, optical loss test set, show spectrum analyzer and Optical Time-Domain Reflectometer (OTDR) are instruments commonly used for this purpose [2].

The calibration procedures for optical fiber power meters, wavelength measurement instruments, and OTDRs have been standardized by IEC 61749 [3], IEC 61278 [4], and IEC 61746 [5], respectively. Standardization plays an important role in guaranteeing the performance of the optical measurement equipment. The international standard for the calibration of visible laser sources, IEC 61272, has not yet been finalized [1].

SCL has developed a calibration system for optical fiber laser sources fitted with FC/APC connectors at 1310 nm and 1550 nm in the power range of 0.01 mW to 1 mW. The system provides for the calibration of three laser source parameters: output wavelength, output power, and output power stability. Figure 1 shows the metrological traceability of the optical laser source calibration system at SCL. The wavelength is measured by

2. Output Power Calibration Procedures

SCL uses a calibrated ECPR, which is traceable through measurements made by the National Institute of Standards and Technology (NIST) through their Laser Operated Organic Radiometer (LOCR) [6] at 1 mW, to measure the optical laser source power. The block diagram of the measurement setup is shown in Fig. 3. The ECPR has a thermal detector

which has a black, highly absorbent coating. It has an output that is spectrally insensitive over the wavelength regions of interest for photonic equipment calibration. ECPR is frequently used as a laboratory standard because (1) it is sensitive to low power radiation, (2) it is relative spectrally flat, (3) it has low surface reflectance in the 600 nm to 1600 nm wavelength range; and (4) it is insensitive to angle of incidence. The sensor produces an electrical voltage proportional to instantaneous temperature changes, so the

The following sections of this paper detail the optical fiber laser source calibration procedures and list the uncertainty components of each calibration parameter.

NCSLI Workshop & Symposium (2016)

Best Paper Award

Calibration of Optical Fiber Time Domain Reflectometers in Accordance with IEC61749-1:2009

Speaker: Samuel C. K. Ko
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Standards and Calibration Laboratory
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Abstract: This paper describes the calibration system developed by the Standards and Calibration Laboratory (SCL) for calibrating single mode optical time domain reflectometers (OTDR) fitted with FC connectors at wavelength 1310 nm and 1550 nm in accordance with the international standard IEC 61746-1:2009. The parameters calibrated include distance deviation, attenuation deviation and reflectance deviation. The principle of the calibration is to compare a set of reference standards, namely distance calibration artifact, attenuation calibration artifact and reflectance calibration artifacts against the measured values by the OTDR under test. The expanded measurement uncertainties for the distance, attenuation and reflectance deviation calibration are 2 m, 0.04 dB and 1.7 dB respectively.

1. Introduction

Optical time domain reflectometers (OTDR) are widely used in testing, installation and maintenance of optical communication networks. An OTDR launches a series of high speed pulses into a fiber network and measures the amplitude and the delay time of reflected or backscattered signals to locate events or faults along a fiber link. The measured response typically exhibits three types of features as shown in Fig. 1:

- 1) Rayleigh back-scattering;
- 2) Positive spikes caused by discrete Fresnel reflection due to events or faults along a fiber link;
- 3) Steps that can either be positive or negative depending on physical fibre properties.



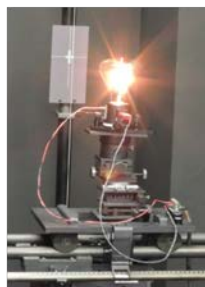
Figure 1. Trace produced by recirculating delay line.



Participation in Inter-laboratory Comparison

APMP Comparison of Luminous Intensity ([APMP. PR-K3.a](#))

Metrology area, branch	Photometry and Radiometry, Photometry
Description	Luminous intensity
Time of measurement	2012 - 2014
Status	In progress
Reference(s)	APMP.PR-K3.a Technical Protocol
Measurand	Luminous intensity in cd
Transfer device(s)	Lamps
Comparison type	Key comparison
Consultative Committee	CCPR (Consultative Committee for Photometry and Radiometry)
Conducted by	APMP (Asia Pacific Metrology Program)



CMS	ITRI Center for Measurement Standards <i>Chinese Taipei, APMP</i>
KazInMetr	Kazakh Institute of Metrology RSE <i>Kazakhstan, COOMET</i>
MSL	Measurement Standards Laboratory of New-Zealand <i>New Zealand, APMP</i>
NIM	National Institute of Metrology <i>China, APMP</i>
NIMT	National Institute of Metrology (Thailand) <i>Thailand, APMP</i>
NIS	National Institute for Standards <i>Egypt, AFRIMETS</i>
NMC, A*STAR	National Metrology Centre, Agency for Science, Technology and Research <i>Singapore, APMP</i>
NMIJ AIST	National Metrology Institute of Japan <i>Japan, APMP</i>
NMISA	National Metrology Institute of South Africa <i>South Africa, AFRIMETS</i>
NML-SIRIM	National Metrology Laboratory, SIRIM Berhad, now NMIM - National Metrology Institute of Malaysia <i>Malaysia, APMP</i>
NPLI	National Physical Laboratory of India <i>India, APMP</i>
Puslit KIM-LIPI	Research Center for Calibration, Instrumentation and Metrology - Indonesian Institute of Sciences <i>Indonesia, APMP</i>
SCL	Standards and Calibration Laboratory <i>Hong Kong, China, APMP</i>
VMI-STAMEQ	Vietnam Metrology Institute, Directorate for Standards and Quality <i>Viet Nam, APMP</i>





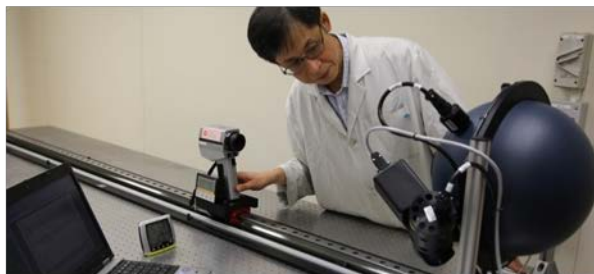
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- The Standards and Calibration Laboratory (SCL)
- Photometry and Radiometry Facilities at SCL
- The Challenges Ahead for SCL
- SCL as an Official CCPR Observer for Hong Kong

On-going Projects for New Capabilities

Luminance Meters

Range : (50 to 1000) cd m^{-2}
Target Completion: Q1 2017

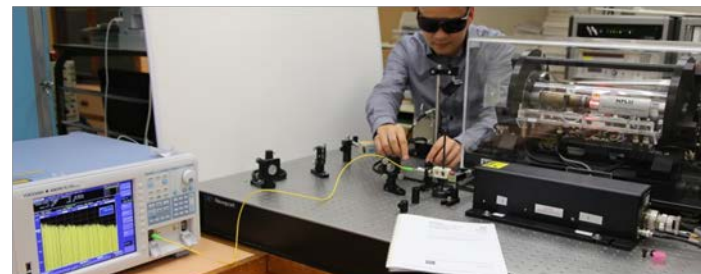
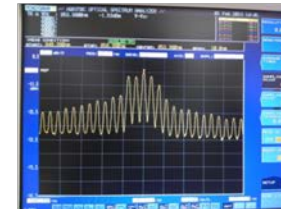


Target clients: airline operators
(e.g. Cathay Pacific Airways)
Applications: for flight simulators



Optical Spectrum Analyzers

Range : (600 to 1700) nm
Target Completion: Q4 2017

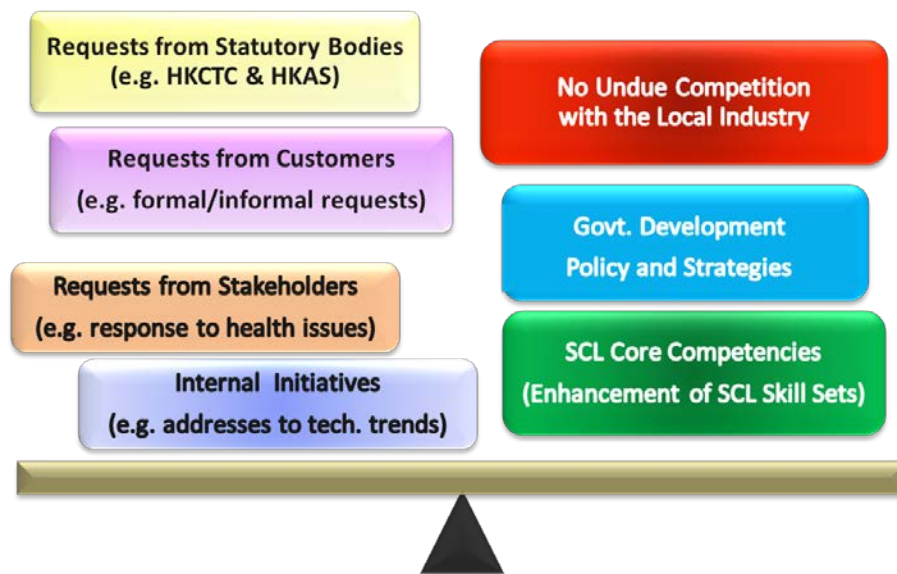


Target clients: Testing laboratories or optical communications manufacturers
Applications: equipment calibration in accordance with IEC 62129-1:2016

New Initiatives for Capability Development

SCL's role is to provide metrology supports to:

- Testing & Certification Industry
 - e.g. needs of accredited organizations
- Optical Communications
 - e.g. fiber optics
- Energy Efficiency
 - e.g. LED lighting





Supporting the Testing & Certification Industry



HKAS endorsed test certificates are accepted by over 70 ILAC MRA Partners from more than 60 economies.



Many T&C organizations have been accredited by the Hong Kong Accreditation Service to provide optical related testing and certification.

Company	Test Category	Test Item	Specific Test
Fugro Technical Services Limited	Environmental Testing	Biosafety Cainetry	Lighting intensity test
Intertek Testing Service Hong Kong Limited	Lamps and Light Fitting	Product performance tests	Luminous flux, Colour temperature, Colour rendering index
		LED	Beam angle, Chromaticity shift, Correlated colour temperature, Lumen maintenance,
Bureau Veritas Hong Kong Limited	Luminaries	Compliance Inspection and Safety Tests	Various

Company	Test Category	Test Item	Specific Test		
TUV Rheiland Hong Kong Limited	Luminaries	Compliance Inspection and Safety Tests	Spectacles		
DEKRA Certification Limited				Unmounted lens for non-prescription sunglasses	Optical requirements, Optical test methods,
HK Standards and Testing				Lens in non-prescription sunglasses	Physical requirements, Physical test methods,
				Non-prescription sunglasses	Impact-resistance test, Optical properties,
SGS Hong Kong Limited	Textiles and Garments	Colour measurement	Uncut finished spectacle lenses	Physical properties, Test methods.	
UL VS Hong Kong Limited			Uncut finished single-vision & multifocal spectacle lenses	Optical requirements, Optical test methods, Physical requirements, Physical test methods, Impact-resistance test, Optical properties, Physical properties, Test methods.	
			Uncut finished progressive spectacle lenses		
			Uncut finished spectacle lenses		
Bureau Veritas Hong Kong Limited			Solar UV Protective Properties	cleaning EN 13758-1	

SCL is expected to provide calibration services to support them.



Supporting the Telecommunication Industry

Sizes of the Industry (Statistics in 2015):

- Mobile subscriber penetration rate : 227.8 %
- Mobile subscriber: 16,684,735
- Household broadband penetration rate: 84.7 %
- Registered broadband household: 2,364,736

Service demands:

- Telecommunication operators
- Testing laboratories
- Public utilities
- Regulatory Bodies (Govt. Depts)

Typical calibration service:

- Optical spectrum analyzers
- Optical fibre characterization
- Optical power meters
- Wavelength meters
- Optical attenuators
- Optical Time Domain Reflectometer
- Others



Supporting Environmental Friendly Lighting

In HK, changing lights bulbs to LED lighting is a huge project, which involves:

Hong Kong International Airport (one of the world's busiest airport)

- Passengers: 68.5 million per year
- Cargo handled: 4.38 million tons per year
- Air traffic movements: 406,000 planes per year



Hong Kong Railway System (one of the world's busiest railway systems)

- Lines: 22
- Length: over 210 km
- Stations: 87
- Daily passengers: 5.2 million people



Hong Kong's Public Housing Estates (one of the world's largest housing provider)

- 29 % of Hong Kong's population
- Units: 782,700
- Tenants: 2.12 million people





Optical Measurement for Energy Efficiency

Statutory requirements, guidelines, codes of practices and schemes are issued for law enforcement, which demands metrology supports.

The Hong Kong Voluntary Energy Efficiency Labelling Scheme for Light Emitting Diode (LED) Lamp

機電工程署 EMSD

ENG 繁體 简体

《建築物能源效益條例》
The Buildings Energy Efficiency Ordinance

空調裝置
Air-conditioning installation

電力裝置
Electrical installation

升降機及自動梯裝置
Lift & escalator installation

照明裝置
Lighting installation

Energy Audit Form
能源審核表格

January 2014

Efficiency EMSD
Electrical and Mechanical Services
Department
3 Kai Shing Street, Kowloon, Hong Kong
Homepage: <http://www.emsd.gov.hk>

Energy Efficiency and
Conservation for Buildings
建築物能源效益及節約指南



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SCL would like to join CCPR as an observer

- Work in photometry and radiometry at SCL is in line with CCPR activities
- SCL would like to participate in CCPR working groups and workshops in order to stay at the metrological forefront and strategically positioned in future metrology development
- SCL would like to participate in CCPR meetings in order to network with experts of the field as well as to contribute its views and experience



Thank You

